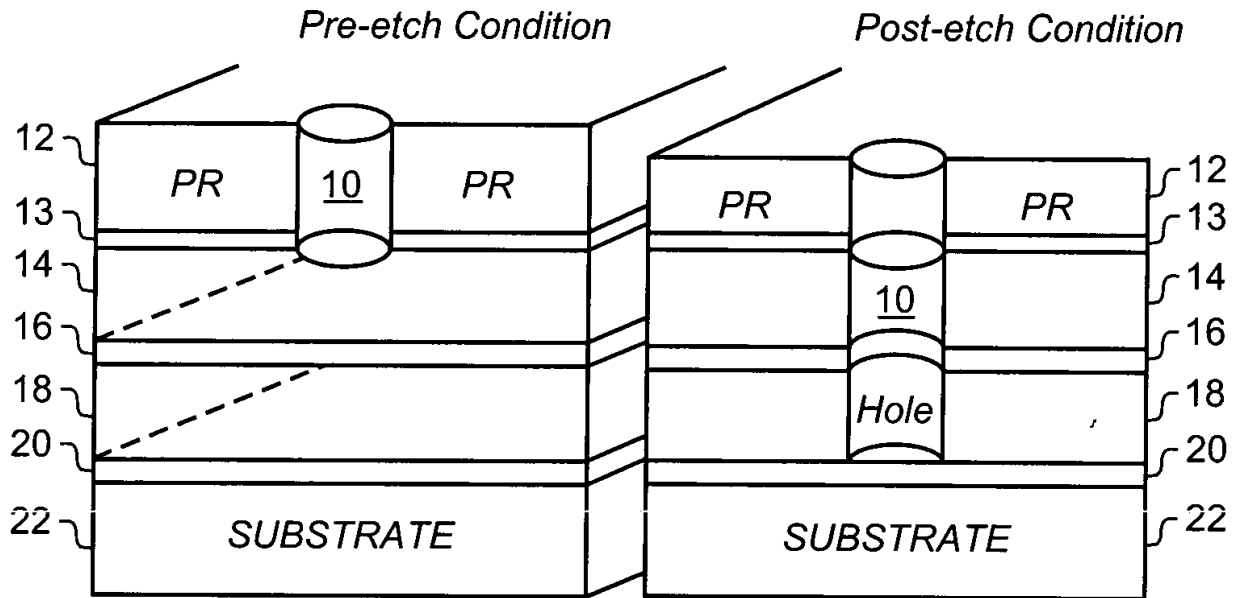
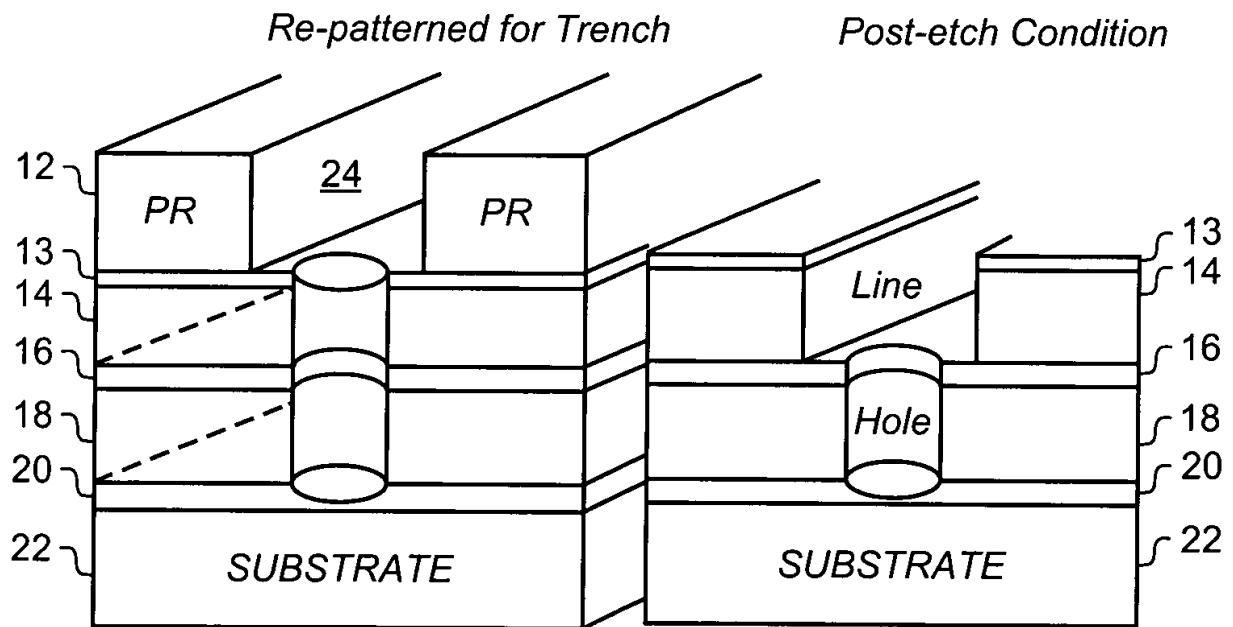


APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
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*FIG. 1A*

*FIG. 1B*



*FIG. 1C*

*FIG. 1D*

APPROVED	O.G. FIG.	
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ATTORNEY: FILING DATE: MARCH 30, 2001  
 TITLE: METHOD OF PLASMA ETCHING  
 INVENTOR(S): HELEN H. ZHU ET AL.  
 APPLICATION SERIAL NO: 09/820,694

CON...

SHEET 2 of 7

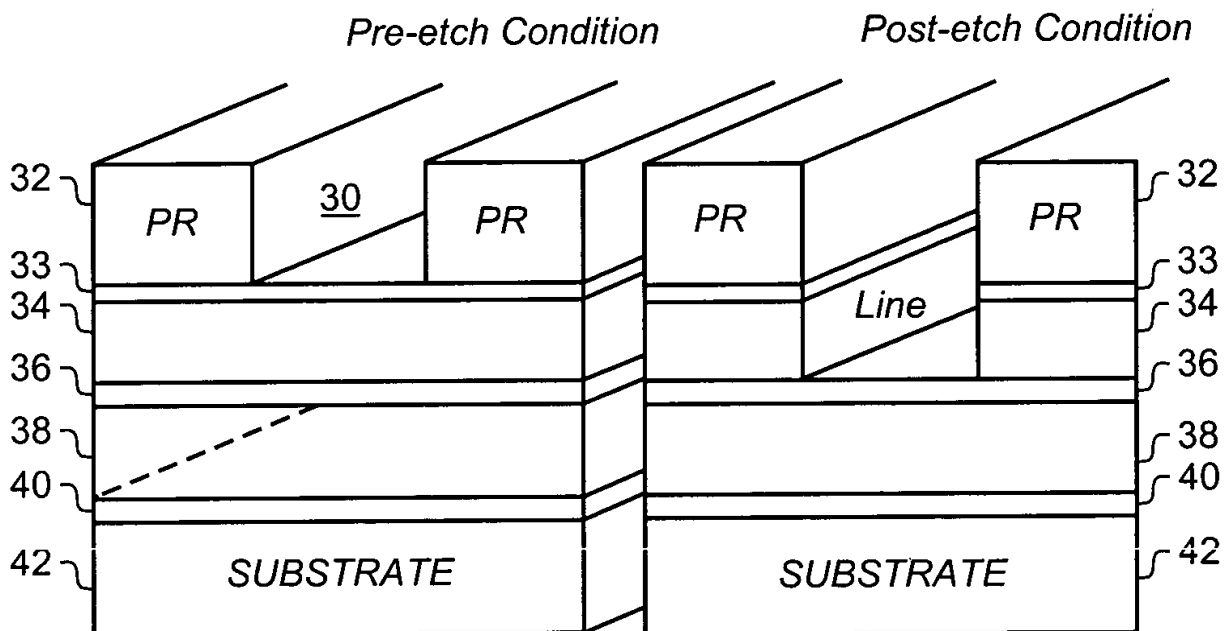


FIG. 2A

FIG. 2B

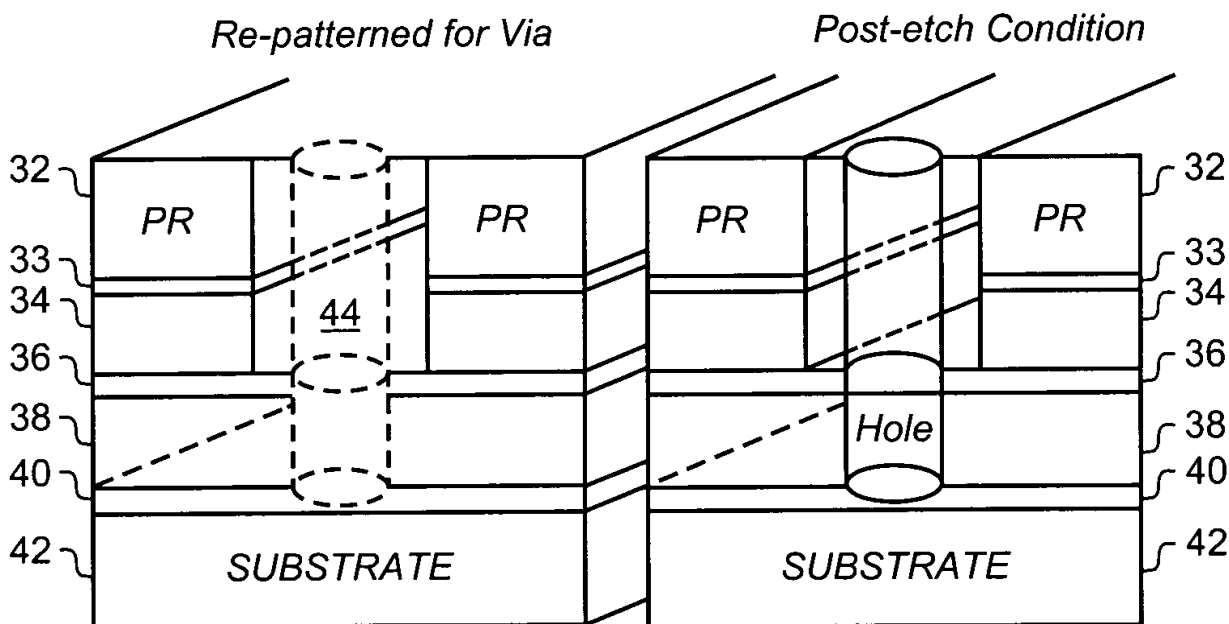
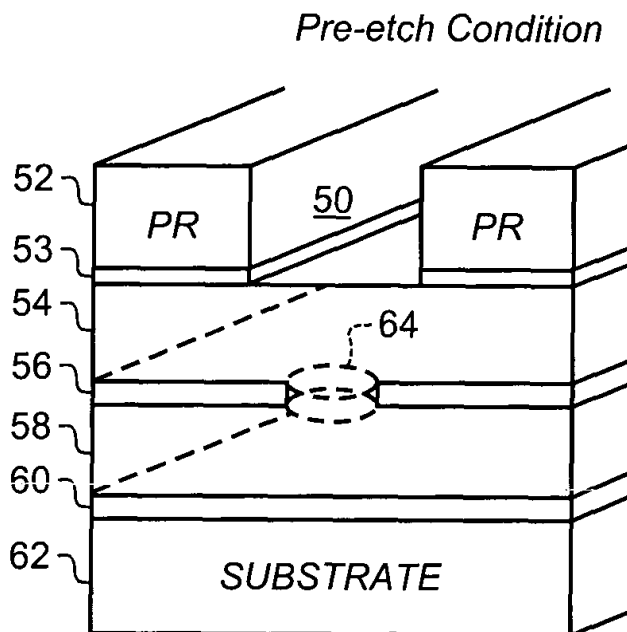


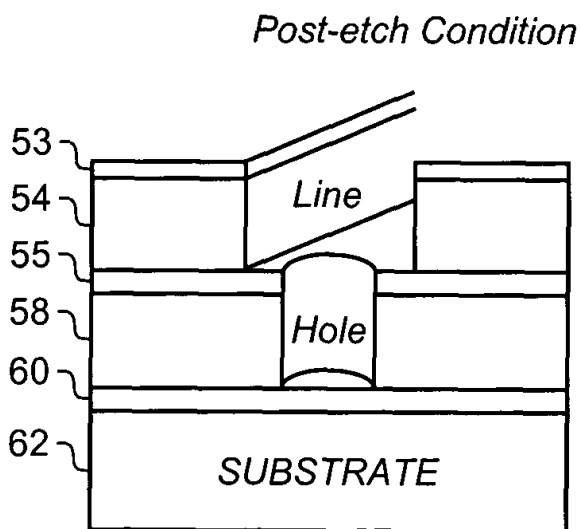
FIG. 2C

FIG. 2D

APPROVED	O.G. FIG.	
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**FIG. 3A**



**FIG. 3B**

APPROVED	O.G. FIG.	
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SHEET 4 of 7

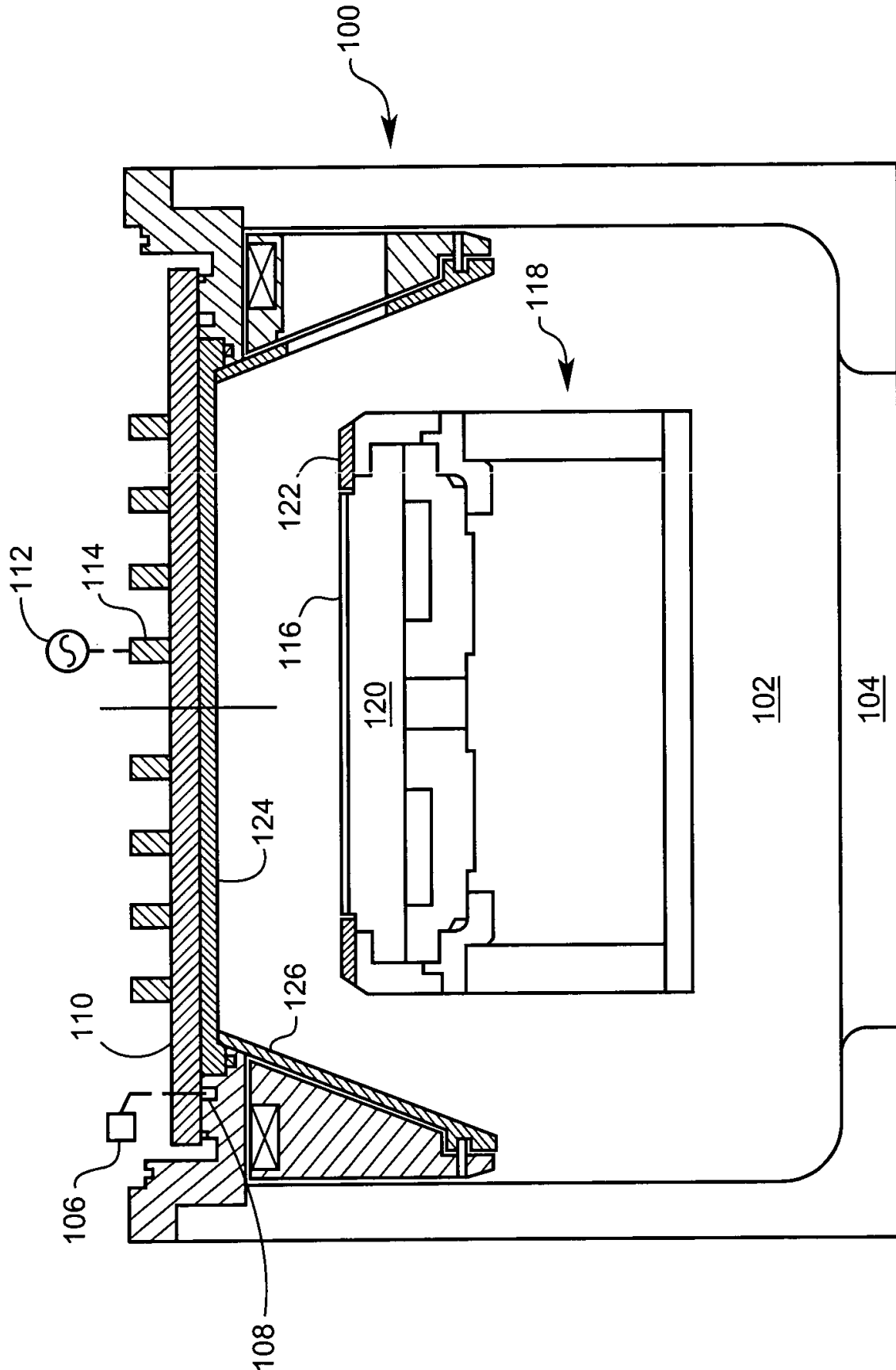


FIG. 4

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
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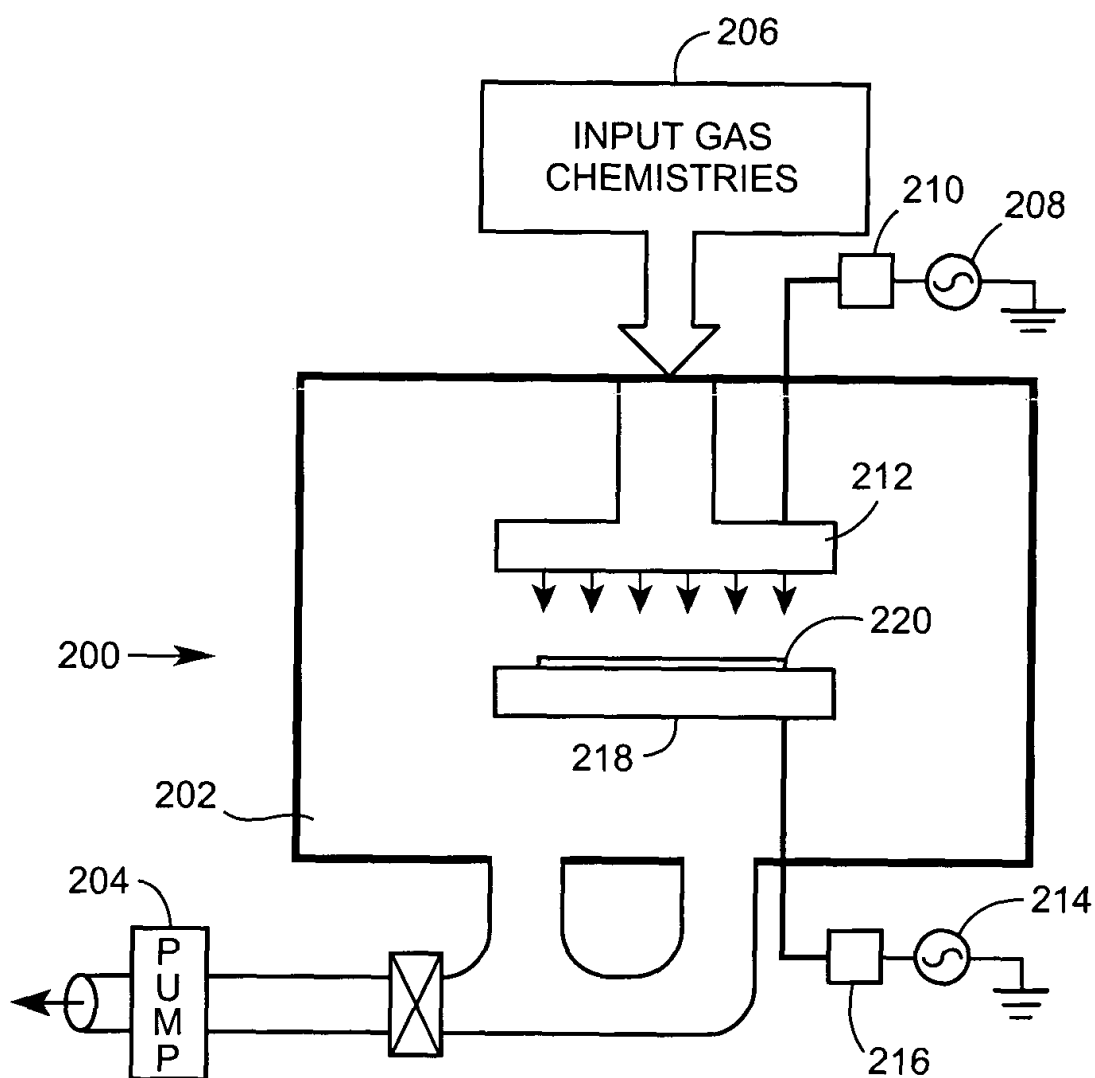


FIG. 5

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
DRAFTSMAN		

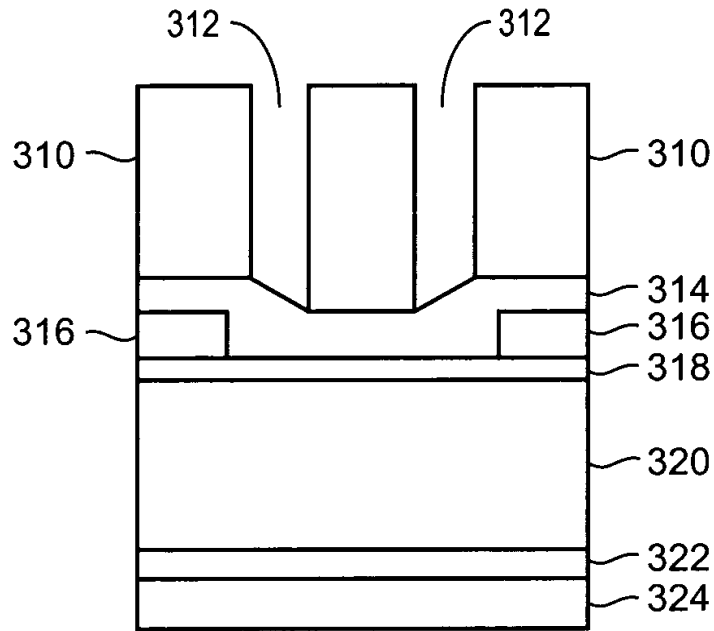


FIG. 6A

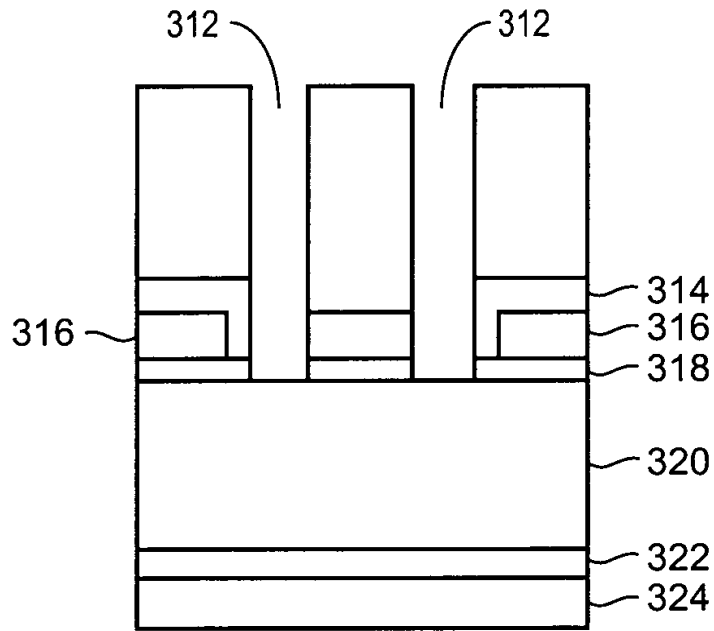


FIG. 6B

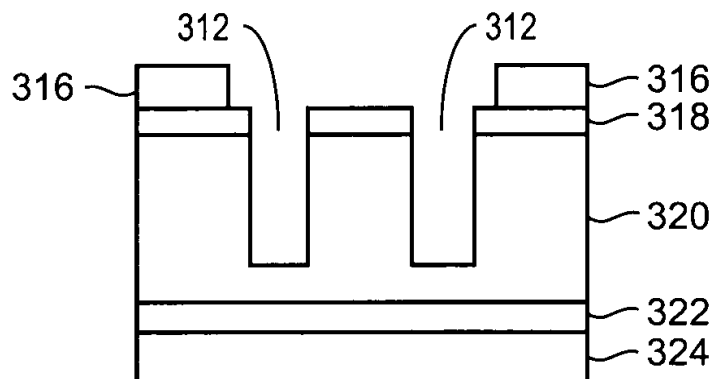


FIG. 6C

APPROVED	O.G. FIG.	
BY	CLASS	SUBCLASS
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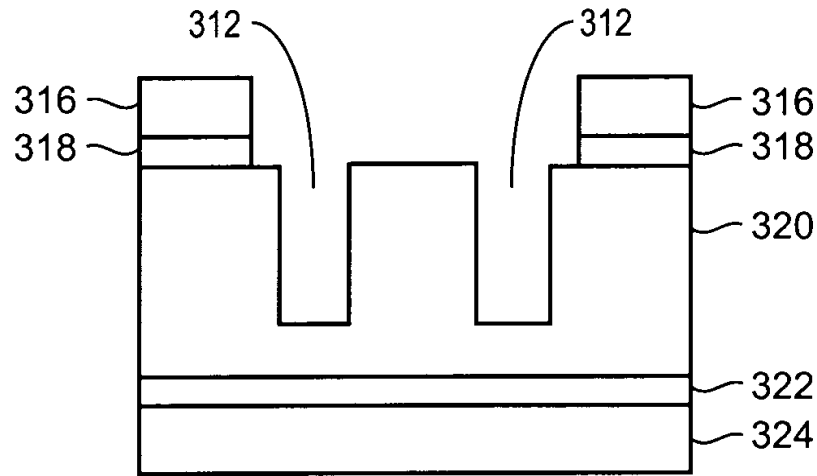


FIG. 6D

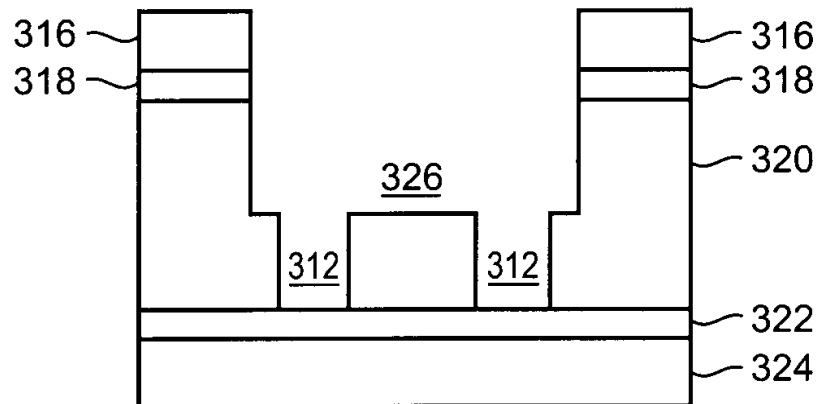


FIG. 6E

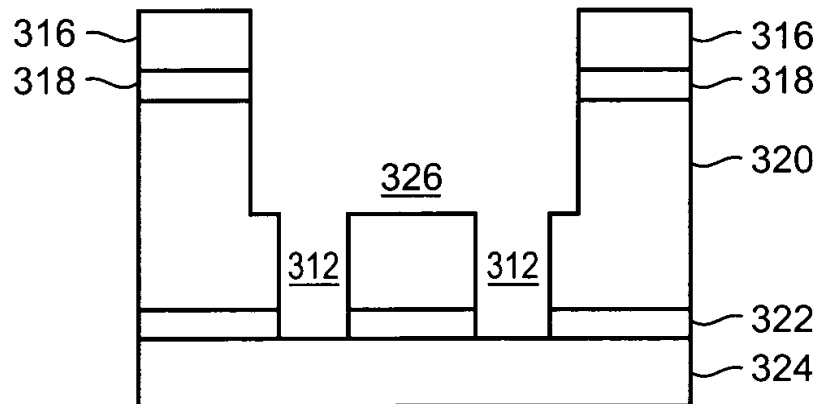


FIG. 6F